Search Notes

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Application/Control	No.

Applicant(s)/Patent under Reexamination

09/726,722

Examiner

HASEGAWA, OSAMU Art Unit

Eva Yi Zheng

2634

SEARCHED			
Class	Subclass	Date	Examiner
375	147	12/15/2005	E.Z
375	344	12/15/2005	E.Z
375	208	12/15/2005	E.Z
375	148	12/15/2005	E.Z
455	434	12/15/2005	E.Z
455	413	12/15/2005	E.Z
455	441	12/15/2005	E.ZE

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
375	344,208	12/15/2005	E.Z	
375	148	12/15/2005	E.Z	
455	413,441	12/15/2005	E.Z	
interference search US- PGPUB (see attachment)		12/15/2005	E.Z	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
updated EAST and IEEE search	12/15/2005	E.Z	
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